



**ELECTRONIC COPY**

LG784620987  
Report verification at [igi.org](http://igi.org)



March 18, 2026  
IGI Report Number **LG784620987**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUSHION MODIFIED BRILLIANT**  
Measurements **10.14 X 7.39 X 5.02 MM**  
**GRADING RESULTS**  
Carat Weight **3.01 CARATS**  
Color Grade **D**  
Clarity Grade **VVS 2**

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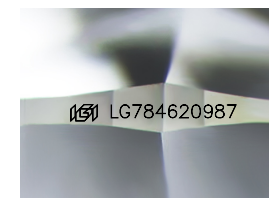
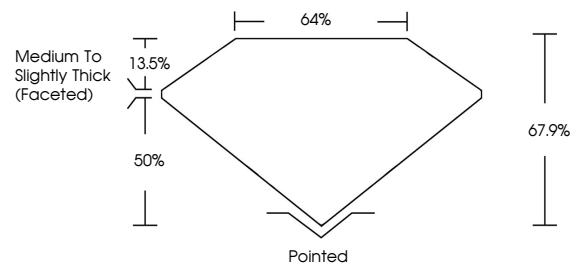
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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG784620987**

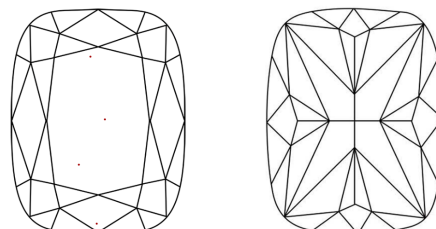
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

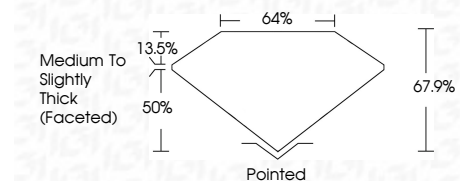
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**CUSHION MODIFIED BRILLIANT**  
**10.14 X 7.39 X 5.02 MM**  
3.01 CARATS  
D  
VVS 2  
67.9%  
64%  
Medium to Slightly Thick (Faceted)  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG784620987  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa